



JPW

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q76863

Toshinobu OGATSU

Appln. No.: 10/694,841

Group Art Unit: 2851

Confirmation No.: 2499

Examiner: Fuller, Rodney Evan

Filed: October 29, 2003

For: WAFER SUPPORT DEVICE AND A WAFER SUPPORT METHOD

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 29, 2005, please amend the above-identified application as follows on the accompanying pages.

**TABLE OF CONTENTS**

AMENDMENTS TO THE SPECIFICATION.....	2
AMENDMENTS TO THE CLAIMS .....	3
REMARKS .....	9